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**PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kenji NISHI

Group Art Unit: 2851

Application No.: 10/026,909

Examiner: H. Nguyen

Filed: December 27, 2001

Docket No.: 111586

For: MANUFACTURING METHOD IN MANUFACTURING LINE, MANUFACTURING  
METHOD FOR EXPOSURE APPARATUS, AND EXPOSURE APPARATUS

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

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JUL 31 2003  
TECHNOLOGY CENTER 2800

In reply to the July 7, 2003 Office Action, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims;

**Remarks.**